



IPW

PATENT  
Customer No. 22,852  
Attorney Docket No. 2887.0259-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Junji SUGAMOTO et al. ) Group Art Unit: 2825  
Application No.: 10/706,090 ) Examiner: LEE, Granvill D  
Filed: November 13, 2003 )  
For: SEMICONDUCTOR WAFER ) Confirmation No.: 7292  
TREATMENT METHOD, )  
SEMICONDUCTOR WAFER )  
INSPECTION METHOD, )  
SEMICONDUCTOR DEVICE )  
DEVELOPMENT METHOD AND )  
SEMICONDUCTOR DEVICE )  
TREATMENT APPARATUS )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action mailed September 17, 2004, the period for response  
extending through December 17, 2004, please amend the above-identified application  
as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment sections of this paper.